

## PATENT APPLICA

2891

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

August 29, 2008 Date

In re the Application of

Noriyoshi SATO et al.

Group Art Unit:

Examiner: C. EVERHART Application No.: 10/539,569

Docket No.: 124305 Filed: August 18, 2005

For: PLASMA GENERATOR, OZONE GENERATOR, SUBSTRATE PROCESSING

APPARATUS AND METHOD OF MANUFACTURING SEMICONDUCTOR DEVICE

LARGE ENTITY PETITION FOR 1st - 3rd EXTENSION OF TIME UNDER 37 C.F.R. §1.136(a) AND TRANSMITTAL OF FEE UNDER 37 C.F.R. §1.17

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

Transmitted herewith is a response to the outstanding Official Action in the above-identified patent application. The shortened statutory period having expired August 1, 2008, an extension of time for a period of one month is hereby requested. Attached hereto is our Check No. 209470 in the amount of \$120 in payment for:

X	Extension fee for response within first month pursuant to §1.136(a) (\$120.00)
	Extension fee for response within second month pursuant to §1.136(a) (\$460.00)
	Extension fee for response within third or subsequent month pursuant to §1.136(a) (\$1050.00)

The Commissioner is hereby authorized to charge any additional fee or credit any overpayment associated with this communication to Deposit Account No. 15-0461.

Respectfully submitted

Registration No. 27,075

Linda M. Saltiel Registration No. 51,122

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DEPOSIT ACCOUNT USE

**AUTHORIZATION** Please grant any extension necessary for entry; Charge any fee due to our Deposit Account No. 15-0461

JAO:LMS/mdw

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